

## **ANSI/OESC TAG to ISO/TC 172/SC 3 Annual Report for 2011**

**Prepared by TAG/SC 3 Leader:** Gordon Boulton

**Number of Meetings Held during 2011:** 1

Date: October 13, 2011

Location: Okinawa, Japan

**Number of Meetings Scheduled for 2012:** 0

Location: N/A

### **List any significant accomplishments for ANSI/OEOSC TAG/SC 3 this year.**

Indicated abstain/no interest in a WG 1 NWIP for a test method for homogeneity of optical glasses by laser interferometry. (It will go forward as a WD anyway.)

Voted affirmatively on a WG 3 NWIP for a test method for refractive index of IR materials, and Dr. Hanssen provided extensive inputs. It will go forward as a WD. Dr. Leonard Hanssen and Gordon Boulton agreed to participate.

Voted to confirm ISO 9211-3:2008 without changes.

Provided US comments on WG 2 project to ISO CD 9211-4 for *Optical coatings — specific test methods*. This is a revision to the document and incorporates a draft amendment. The US chairs this project.

The US (JDSU) supplied samples for a comparison test of the cheesecloth abrasion tester pad preparation methodology.

### **List any problems encountered by the ANSI/OEOSC TAG/SC 3 during the year**

As of the date of this report, none of the IR materials suppliers or users who have expressed an interest in participating in WG 3 have joined OEOSC.

It is not a “problem” but TAG/SC 3 should provide the SC 3 Secretariat with information on whether the US would be interested in hosting a joint SC 1/SC 3 meeting in 2013. Currently Japan has agreed to host the SC 3 meeting in Japan in 2013 but the US has agreed to host an SC 1 meeting that year.